

Electronic Patent Application Fee Transmittal

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|---------------------------------------------|-----------------------------------|-----------------|---------------|-----------------------------|
| Application Number: | 10802811 | | | |
| Filing Date: | 18-Mar-2004 | | | |
| Title of Invention: | Plasma processing apparatus | | | |
| First Named Inventor/Applicant Name: | Tetsuji Sato | | | |
| Filer: | Marvin Jay Spivak/Sachie Fazzzone | | | |
| Attorney Docket Number: | 250645US2 | | | |
| Filed as Large Entity | | | | |
| Utility Filing Fees | | | | |
| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
| Basic Filing: | | | | |
| Pages: | | | | |
| Claims: | | | | |
| Miscellaneous-Filing: | | | | |
| Petition: | | | | |
| Patent-Appeals-and-Interference: | | | | |
| Post-Allowance-and-Post-Issuance: | | | | |
| Extension-of-Time: | | | | |
| Extension - 3 months with \$0 paid | 1253 | 1 | 1050 | 1050 |

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-----------------------------------|----------|----------|--------|----------------------|
| Miscellaneous: | | | | |
| Request for continued examination | 1801 | 1 | 810 | 810 |
| Total in USD (\$) | | | | 1860 |